

Abstract

Apparatus And Method For Pulling A Single Crystal Of Semiconductor Material

- 5 Apparatus for pulling a single crystal (1) of semiconductor material from a melt (7) contained in a crucible (8), having a device (20) for rotating a pulling shaft (14) and having a device (21) for rotating a crucible shaft (13), characterized by a double worm gear between a drive (22) and the pulling shaft (14) and by a further double worm gear between a further drive (31) and the crucible shaft (13).
- 10 Method for pulling a single crystal of semiconductor material using the apparatus.

Drawing for the Abstract: Fig. 2